

<b>Notice of References Cited</b>	Application/Control No. . 10/004,535	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Jorge L Ortiz-Criado	Art Unit 2655	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,043,935	03-2000	Lee, Wai-Hon	369/112.15
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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